



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Francois Templier et al. CONFIRMATION NO.: 5812  
APP. NO.: 10/526,641 ART UNIT: 2815  
FILING DATE: March 2, 2005 EXAMINER: Edward J. Wojciechowicz  
TITLE: Quasi-Vertical Power Semiconductor Device on a Composite Substrate

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**CERTIFICATE OF MAILING**

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the date printed below:

Date: January 7, 2008

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Sharon E. Byam

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**Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450**

**RESPONSE TO OFFICE ACTION**

This responds to the Office Action dated July 5, 2007 in the above-referenced patent application. Reconsideration of the application is respectfully request in view of the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

This response is accompanied by a Petition for Extension of Time for a period of three months, up to and including January 7, 2008, and the required fee.